



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Batch No. 2071

TOHDA

Allowed: March 12, 2004

Serial No. 10/055,896

Atty Ref.: 925-222

Filed: January 28, 2002

Group: 2811

For: SEMICONDUCTOR DEVICE WITH LAYER Examiner: Nguyen, C.
PEELING RESISTANCE

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Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450


SUBMISSION OF SUPPLEMENTAL DECLARATION

Sir:

Attached hereto is a Supplemental Declaration for the above-referenced application which accurately lists all amendments made in the above-referenced application. It is respectfully requested that this Supplemental Declaration be made of record in this application and replace the original Declaration filed on January 18, 2002.

Respectfully submitted,
NIXON & VANDERHYE P.C.

June 7, 2004

By: 

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